



# Experimental Slice Emittance Reduction at PITZ using Laser Pulse Shaping

Raffael Niemczyk

IPAC 2022 - Rehearsal talk 02.06.2022

Bangkok, 16.06.2022

HELMHOLTZ

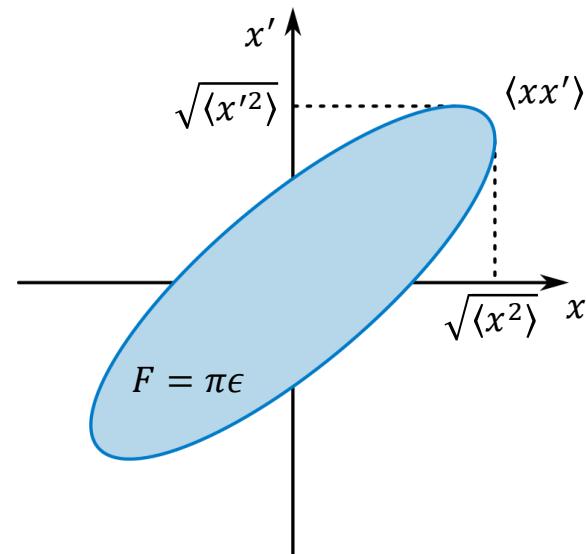


# Free-Electron Laser Performance

## Transverse emittance

- Volume in transverse phase space

$$\epsilon = \beta\gamma\sqrt{\langle x^2 \rangle \langle x'^2 \rangle - \langle xx' \rangle^2}$$



Emittance criterion:  $\epsilon \leq \frac{\lambda_{\text{rad}}}{4\pi} [1]$

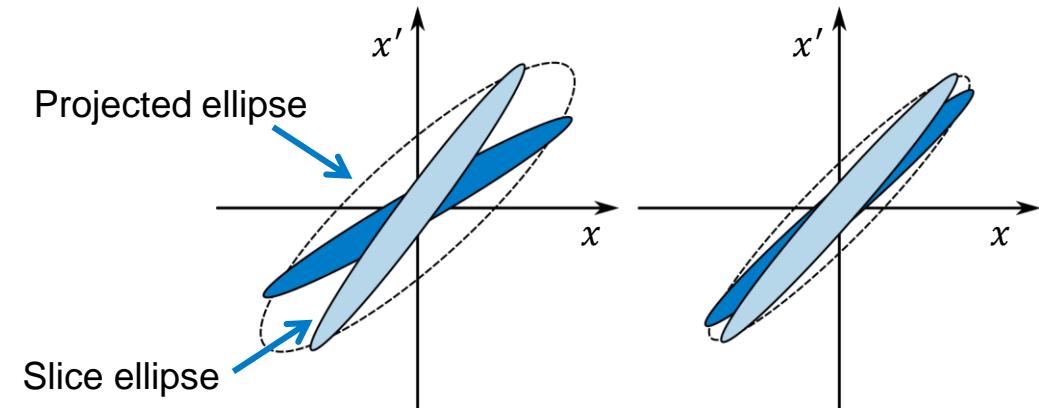
Beam phase space emittance

Radiation phase space volume

## FEL process on fraction of bunch

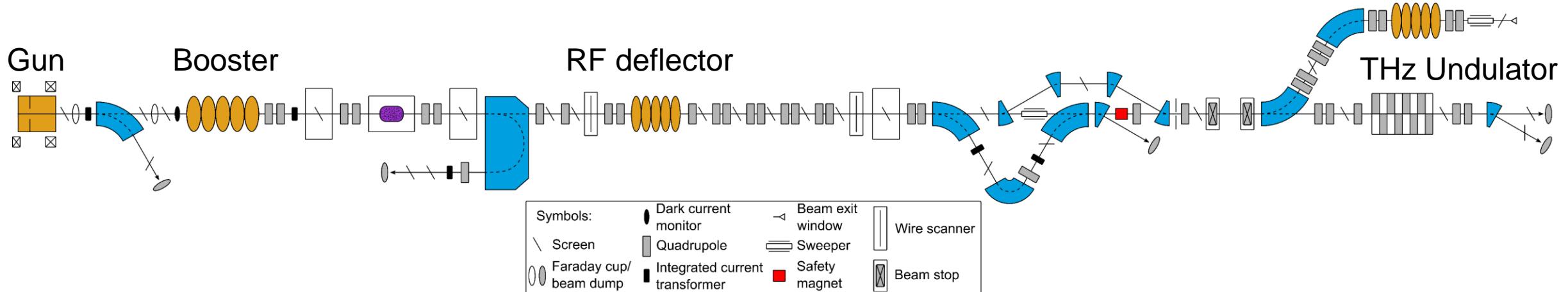
- Slice emittance important
- Slice matching* determines projected emittance

→ Slice emittance measurement crucial



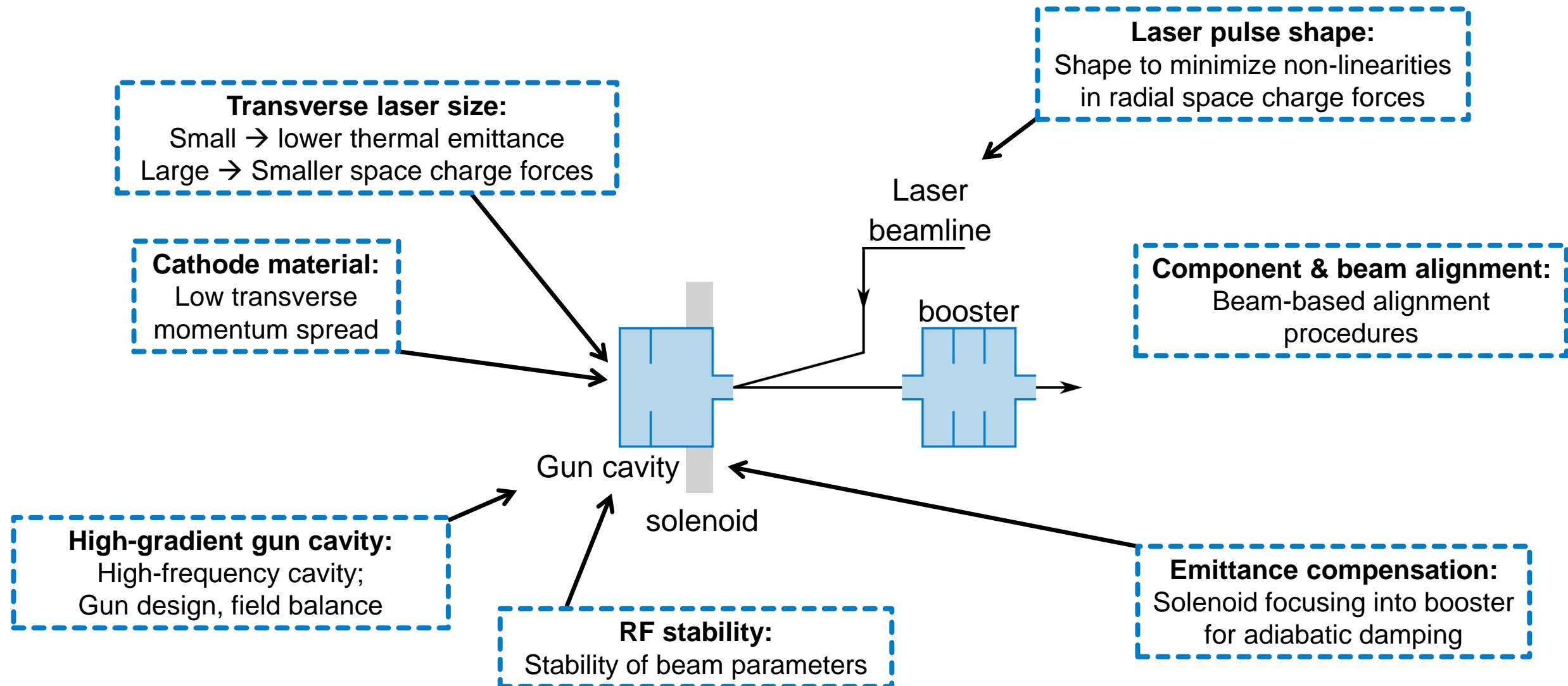
[1] P. Schmüser et al., Free-Electron Lasers in the Ultraviolet and X-Ray Regime, Springer (2014)

# Photoinjector Test Facility at DESY in Zeuthen (PITZ)

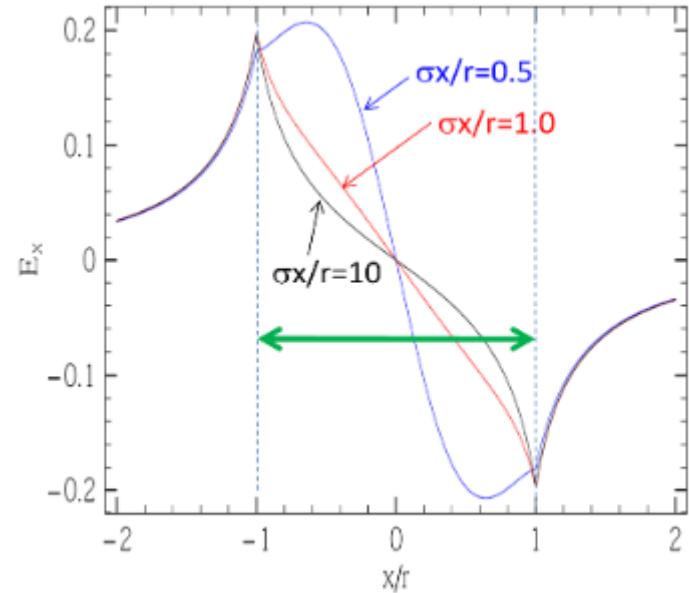


- Test stand for photo electron guns of FLASH & European XFEL
- Beam energy  $\leq 25$  MeV
- High brightness
- Main bunch charges 1 pC – 4 nC
- **Various diagnostics**
  - Emittance
  - RF deflector (TDS)
  - Longitudinal phase space
- **Flexible laser pulse shapes**

# Emittance Optimisation in Photoinjectors



# Emittance optimization using Laser Pulse Shaping

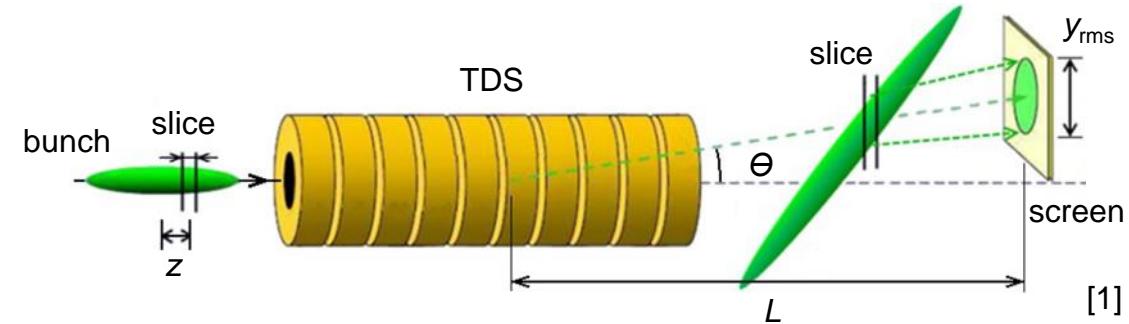


Phys. Rev. ST Accel. Beams 15,  
090701 (2012)

# Transversely Deflecting Structure (TDS)

## Mapping longitudinal to vertical coordinate

- Bunch profile
- Longitudinal phase space
- Time-resolved transverse phase space
  - **Slice emittance**



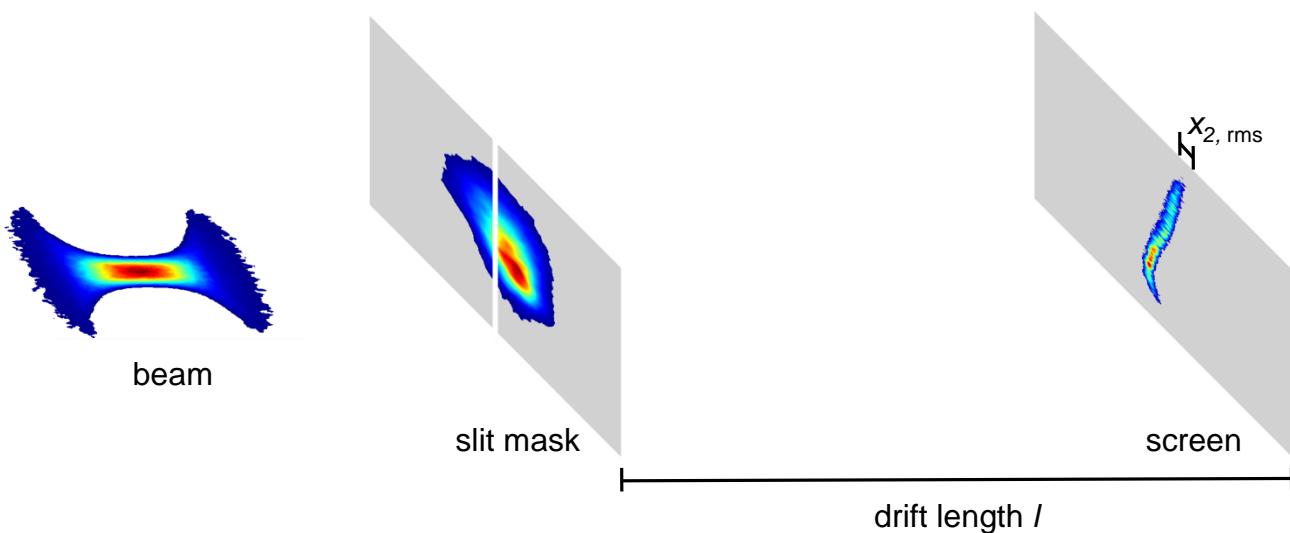
## Properties

- European XFEL prototype
- 3 GHz (S band)
- Pulse length  $\leq 3 \mu\text{s}$ 
  - Deflection of up to 3 bunches
- Deflection voltage 1.7 MV
- Resolution  $\geq 200 \text{ fs}$  (typically)

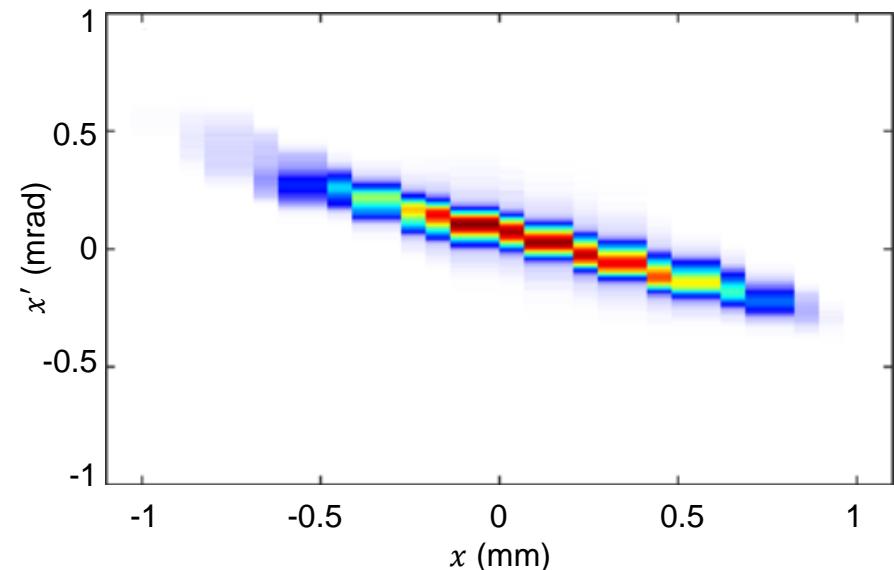


[1] D. Malyutin, Ph.D. thesis, Universität Hamburg, (2014)

# Projected emittance diagnostics

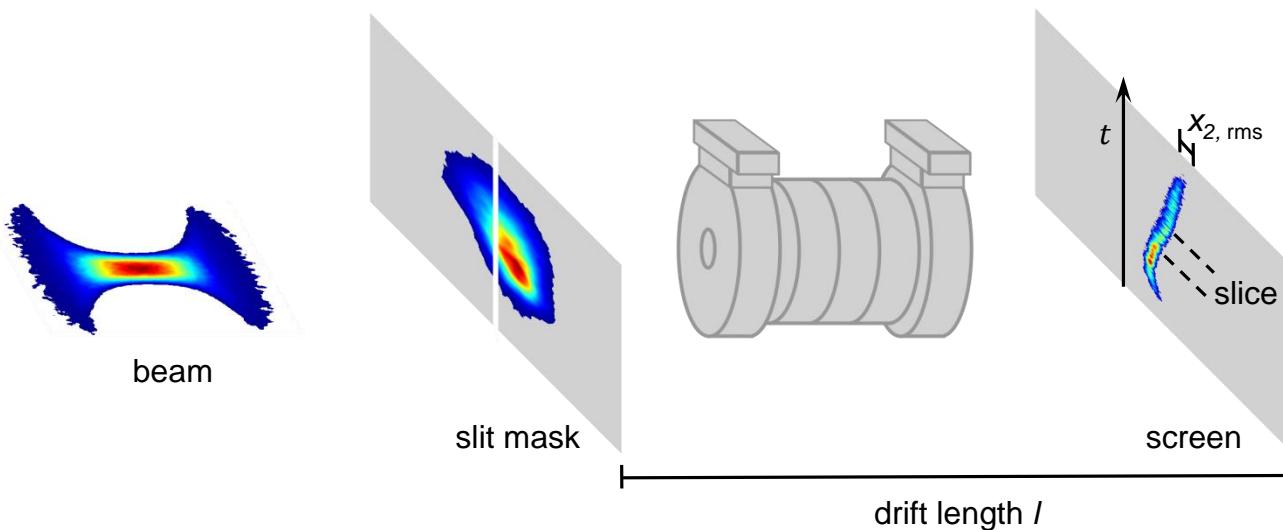


- Cut-out **emittance-dominated beamlets** from **space charge-dominated beam** with slit<sup>[1]</sup>
  - Mapping divergence to beam size:  $x'_1 \rightarrow x_2$
  - Measure **position, divergence, & intensity**
- Reconstruct phase space
  - Emittance calculation via  $\epsilon = \beta\gamma\sqrt{\langle x^2 \rangle \langle x'^2 \rangle - \langle xx' \rangle^2}$

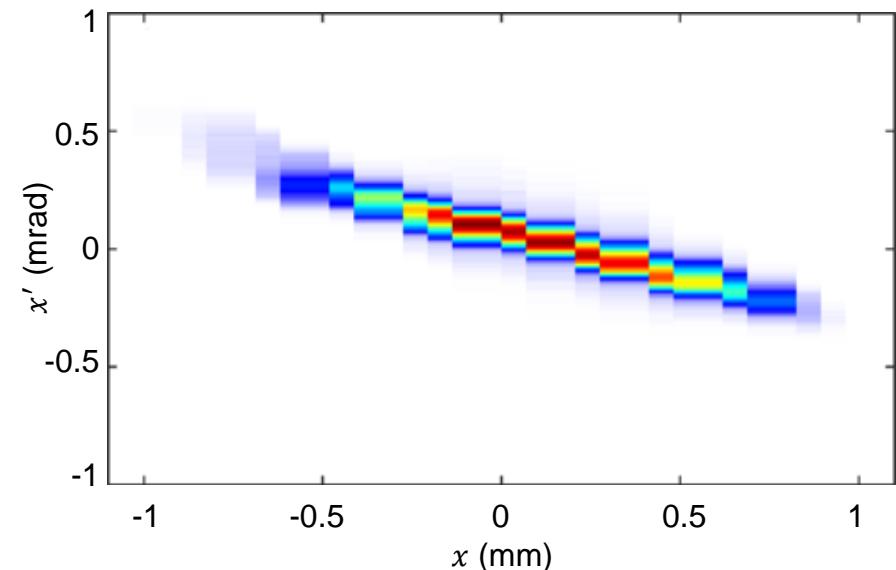


[1] M. Krasilnikov et al., PR STAB **15**, 100701 (2012)

# Slice emittance diagnostics



- Cut-out **emittance-dominated beamlets** from **space charge-dominated beam** with slit<sup>[1]</sup>
  - Mapping divergence to beam size:  $x'_1 \rightarrow x_2$
  - Measure **position, divergence, & intensity** and **time**
- Reconstruct phase space
  - Emittance calculation via  $\epsilon = \beta\gamma\sqrt{\langle x^2 \rangle \langle x'^2 \rangle - \langle xx' \rangle^2}$



[1] M. Krasilnikov et al., PR STAB **15**, 100701 (2012)

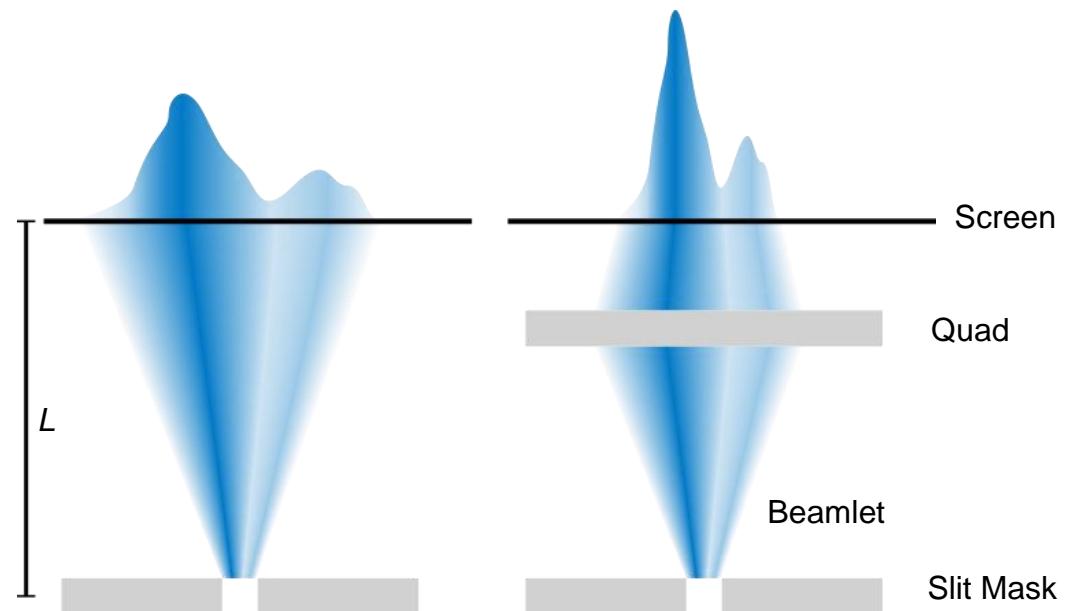
# Challenges

## Obstacles

- Systematic error from *space charge effects*
- Low signal-to-noise ratio (SNR) due
  - Slit mask (reduces charge)
  - TDS deflection, 3 bunches max.
  - Long distance: Slit mask → Screen

## Measures

- Use of high-sensitivity LYSO screen
- Screen station: Moved camera close to screen
- Use of quadrupole magnets behind slit mask
  - Reduce horizontal beam size
  - Increase SNR
  - Improve temporal resolution

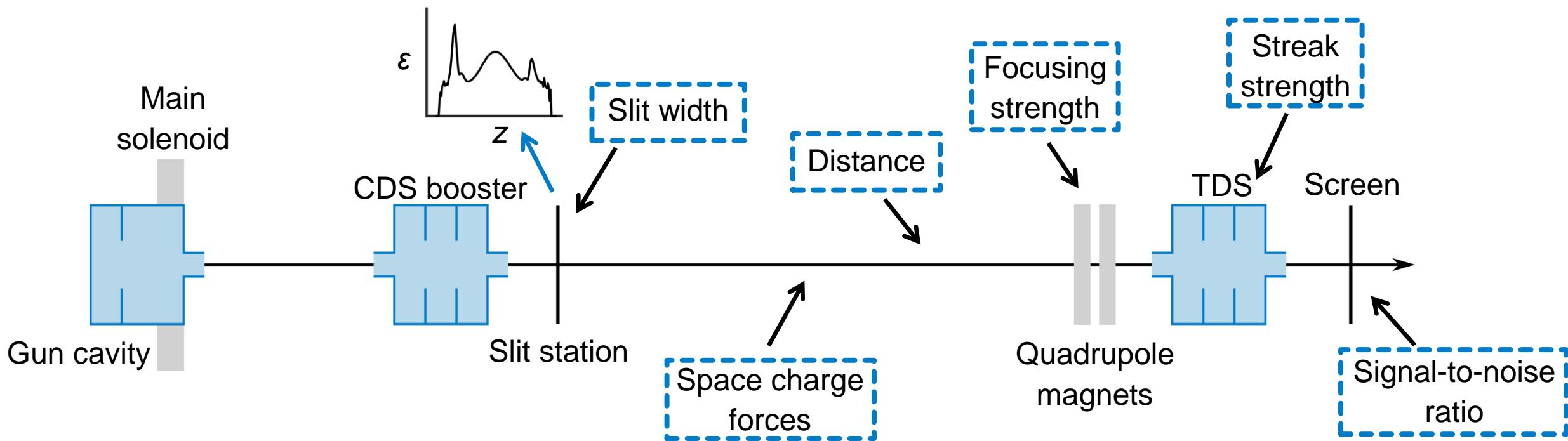


# Systematic error estimation

# Systematic error simulation studies

## Generate standard beam

- Use PITZ standard conditions
- Optimise solenoid focusing strength
- Optimise transverse beam size @ cathode
  - Goal: Lowest projected emittance



# Estimation of systematic error

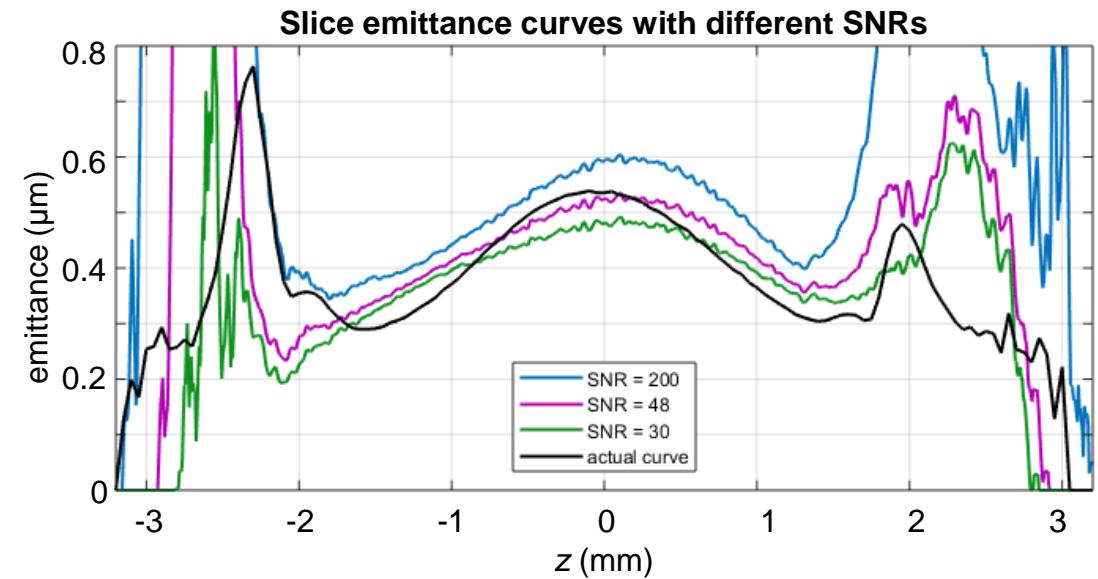
## Slice emittance curve with finite SNR

- SNR > 200, slice emittance overestimation
- SNR ~ 50, correct measurement
- SNR < 50, slice emittance underestimation

## At PITZ

- SNR ~ 50

→ Only minor error

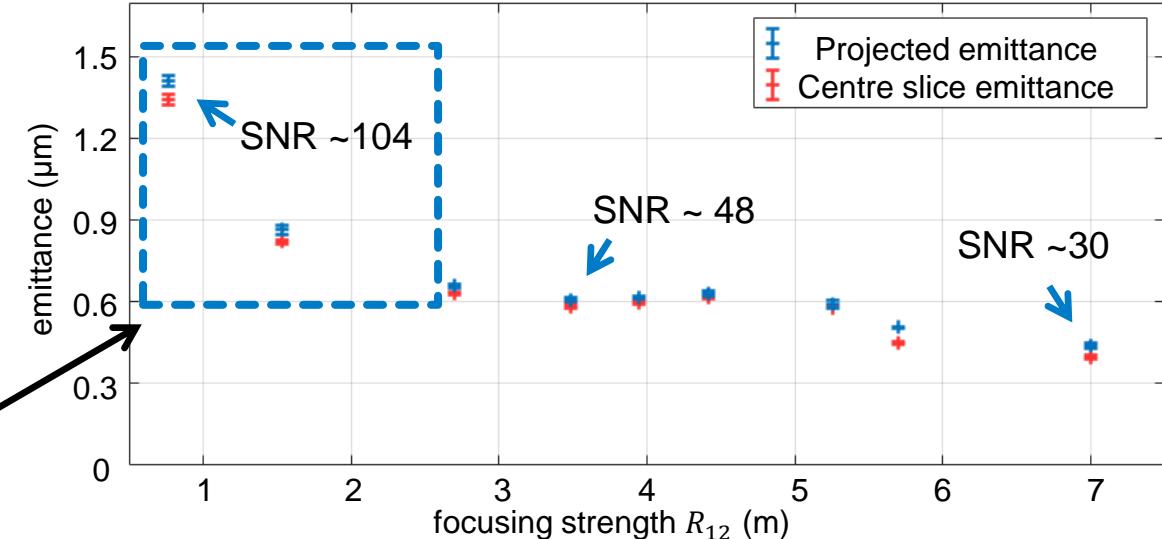


# Estimation of systematic error

## Scan of focusing strength ( $R_{12}$ )

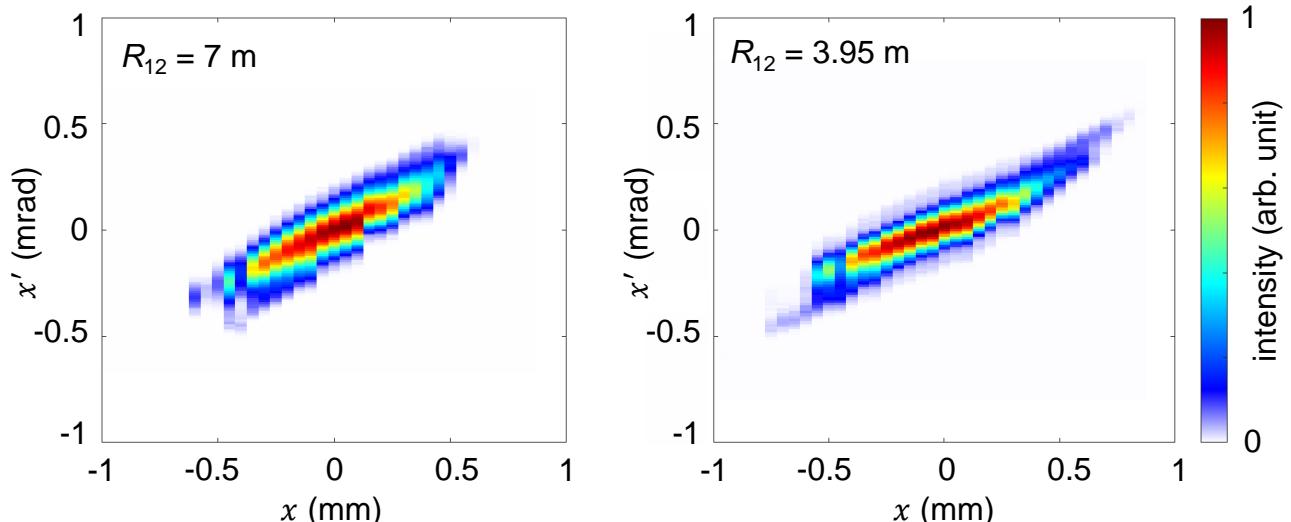
- Measured emittance growth due higher SNR
- Big error at small  $R_{12}$ 's (strong focusing)

Worsening angular resolution &  
Bigger space charge forces  
→ Large error



## Centre slice phase space

- With decreasing  $R_{12}$  SNR increases
- Higher sensitivity
- Low-signal areas become visible



# Beam characterisation

Laser pulse profile	
Temporal	Transverse
Gaussian	Flattop

# Beam characterisation

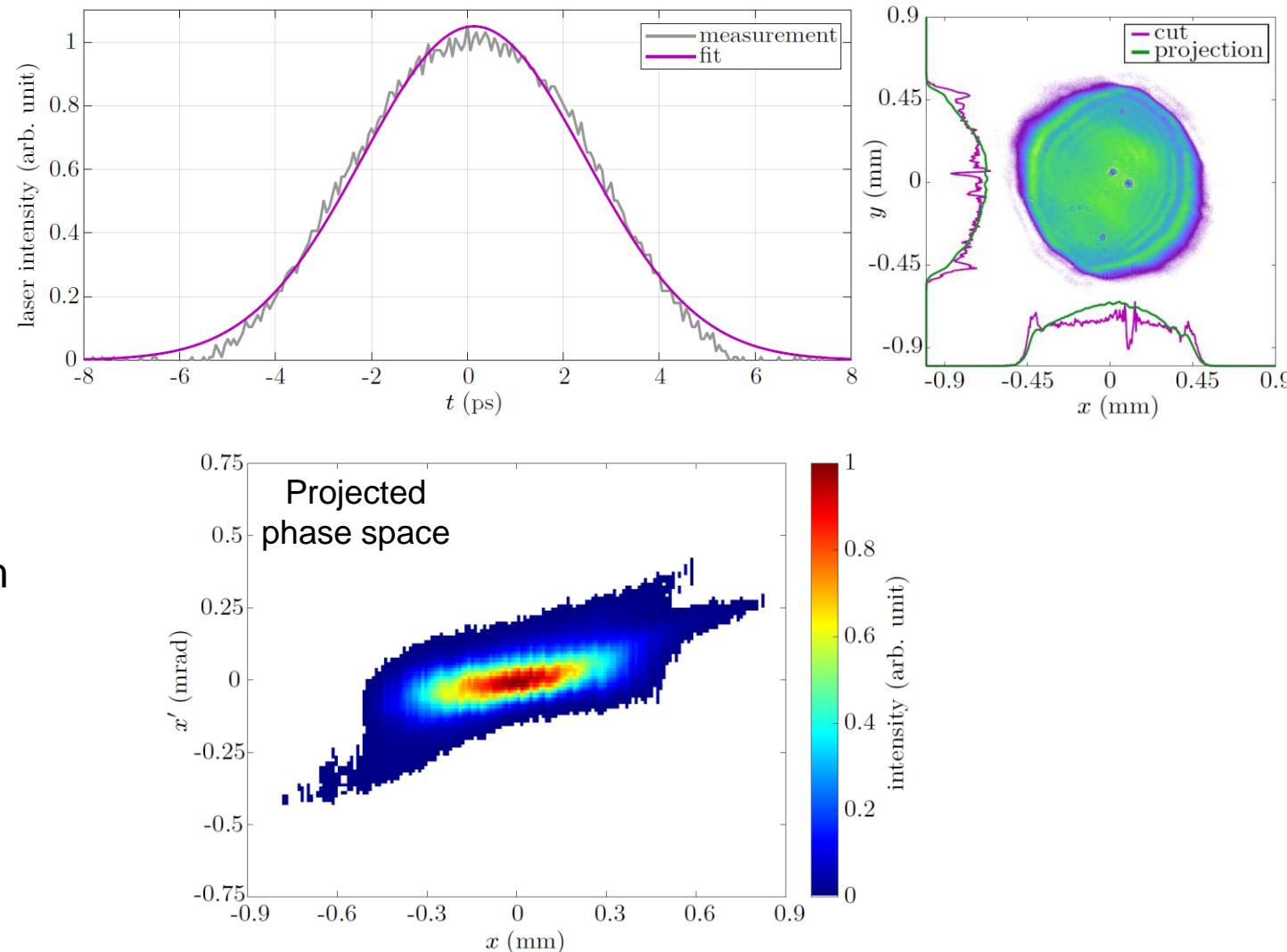
Temporal Gaussian  
Transverse flattop

## Low-emittance beam at EuXFEL conditions

- Transverse flattop laser pulse profile
- Temporal Gaussian laser pulse shape
- 250 pC bunch charge
- Laser pulse length 6 ps (FWHM)

## Solenoid scan for emittance optimisation

- Operation at optimum
- Proj. hor. emittance  $\epsilon_x = 0.53^{+0.09}_{-0.08}$  (syst.)  $\mu\text{m}$

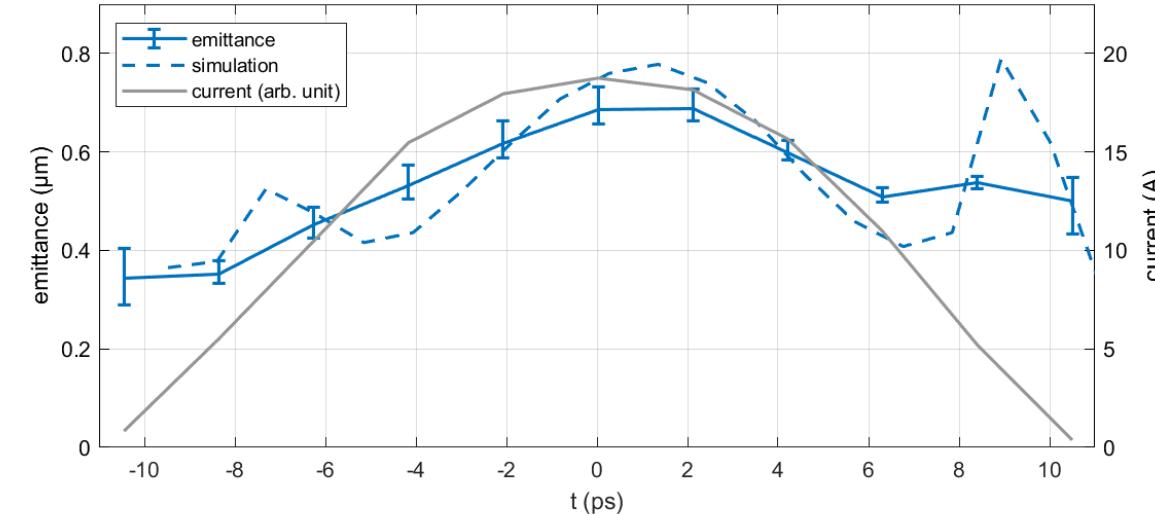


# Slice emittance measurement

Temporal Gaussian  
Transverse flattop

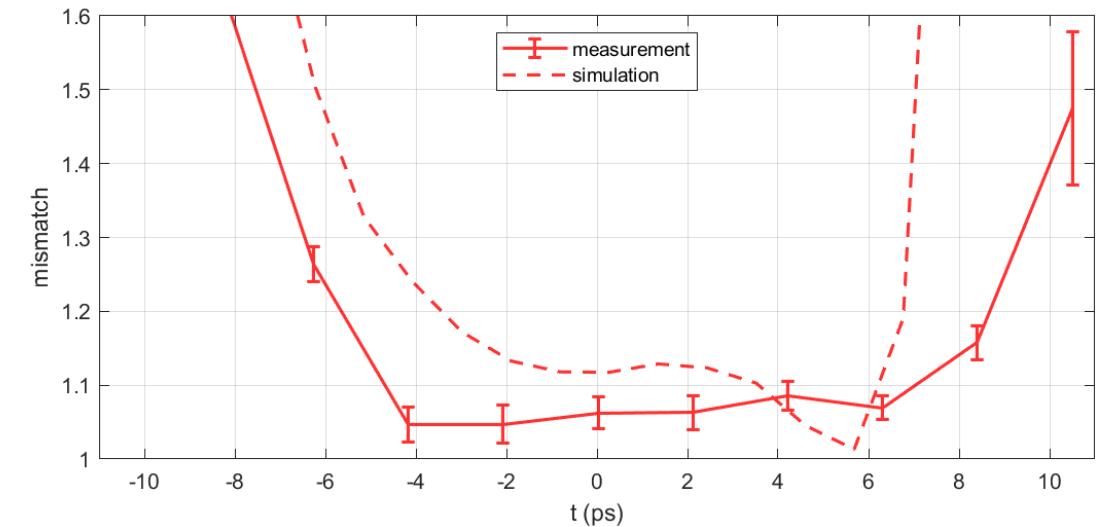
## Emittance curve

- Higher emittance in centre
- Centre slice emittance  $\epsilon_x = 0.69^{+0.05}_{-0.03}$  (stat.)  $\mu\text{m}$
- Emittance reduces towards both tails
- Simulation curve agrees with measurement in centre



## Mismatch

- Small mismatch in centre of bunch
- Large mismatch at both tails
- Simulation: Mismatch similar, but rises closer to centre



# Emittance decomposition

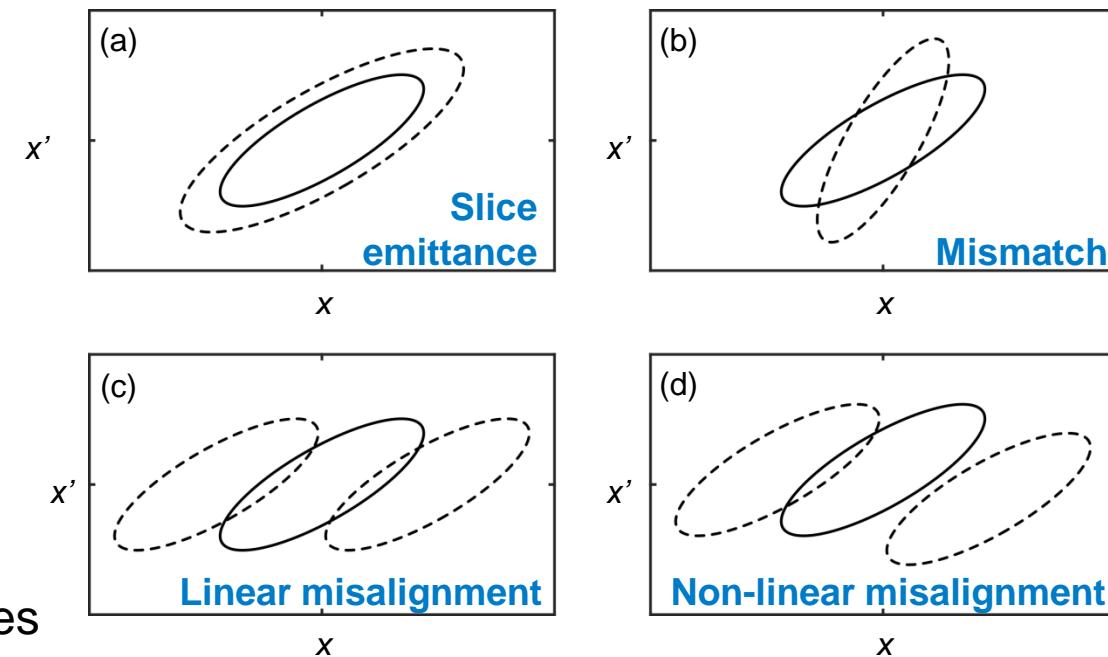
Projected phase space results from slice phase space

$$\text{Projected emittance}^{[1]}: \varepsilon_x^2 = \varepsilon_{\perp}^2 + \varepsilon_R^2 + \varepsilon_{\text{int}}^2 + \varepsilon_{\parallel}^2$$

Mismatch      Linear misalignment  
Slice emittance      Non-linear misalignment

Emittance decomposition allows to identify significant emittance contributions

- High thermal emittance/non-linear radial space charge forces
- Longitudinal variation of transversely focusing forces
- Improper beam trajectory, leading to misalignment



Enables deeper insight into **beam quality optimisation**

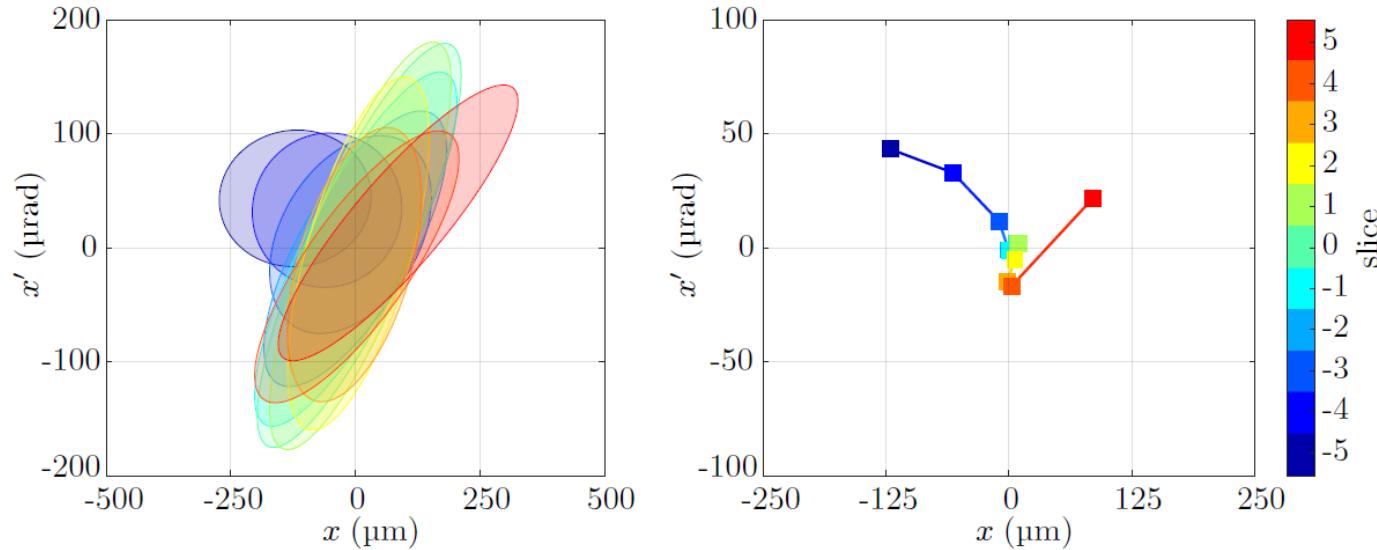
[1] C. Mitchell, *A General Slice Moment Decomposition of RMS Beam Emittance*, (2015).

# Slice emittance measurement

Temporal Gaussian  
Transverse flattop

## Slice phase space ellipses & centroids

- Varying emittance & orientation visible
- (Mostly) linear misalignment visible as well



## Emittance decomposition

- Slice emittance main contribution to projected emittance
- Moderate mismatch contribution
- Misalignment negligible

$\pm \text{FWHM}/2$	Measurement	Simulation
Projected emittance	0.68 μm	0.69 μm
Slice emittance	0.64 μm	0.60 μm
Mismatch emittance	0.25 μm	0.30 μm
Linear misalignment emittance	0.05 μm	0.01 μm
Non-linear misalignment emittance	< 0.01 μm	< 0.01 μm

# Beam characterisation

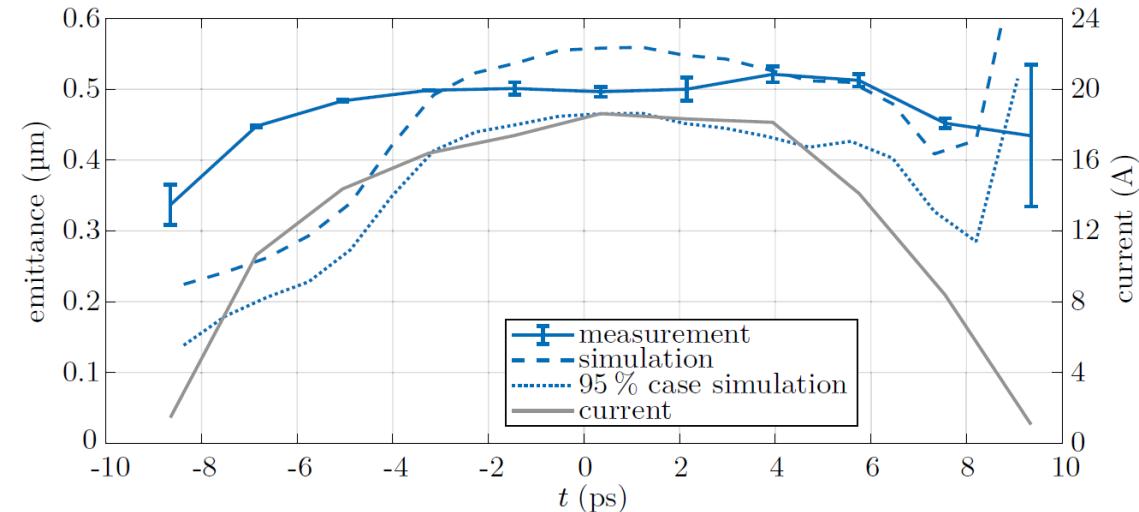
Laser pulse profile	
Temporal	Transverse
Gaussian	Flattop
Flattop	Flattop
Gaussian	Truncated Gaussian

# Slice emittance measurement

## Temporal flattop

## Transverse flattop

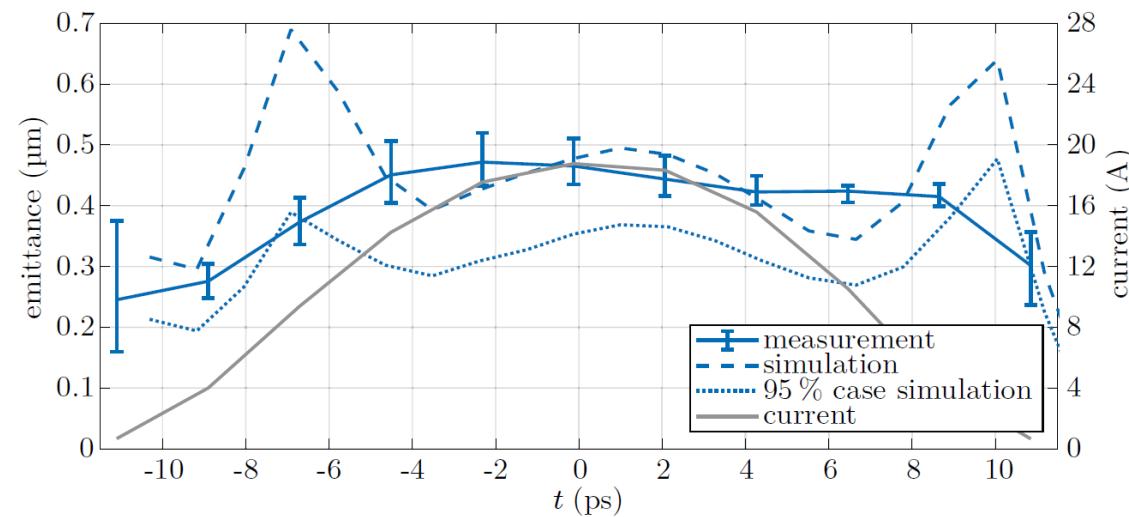
- Centre slice emittance  $\epsilon_x = 0.55 \pm 0.01$  (stat.)  $\mu\text{m}$
- Simulation curve agrees with measurement in centre



## Temporal Gaussian

## Transversely-truncated Gaussian

- Centre slice emittance  $\epsilon_x = 0.47^{+0.05}_{-0.03}$  (stat.)  $\mu\text{m}$
- High emittance at both tails

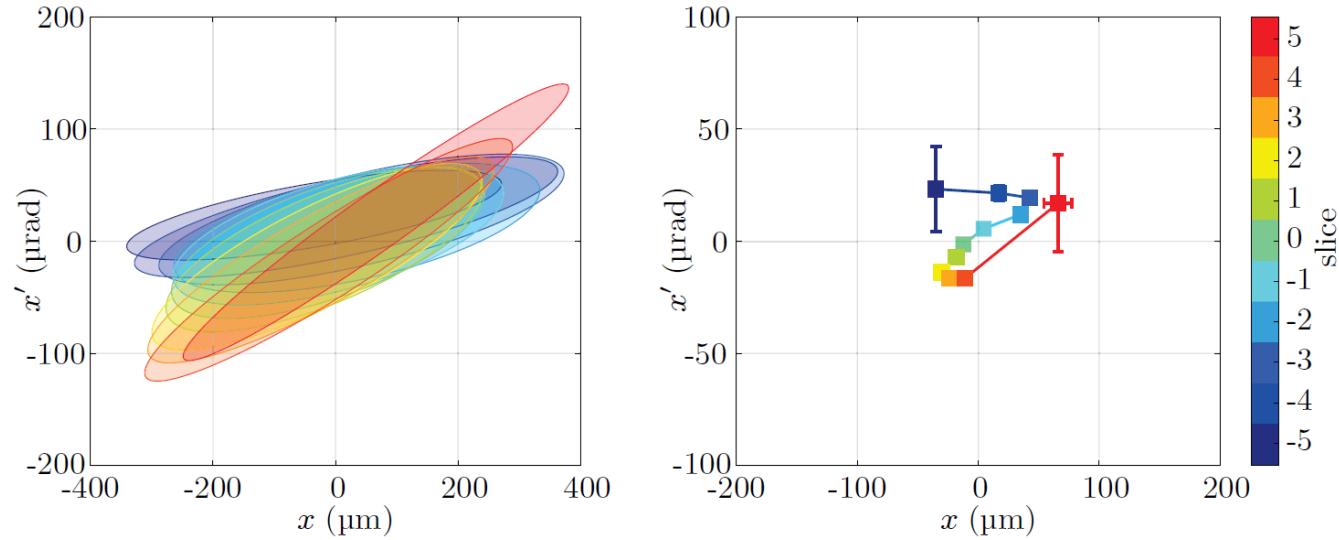


# Slice emittance measurement

Temporal flattop  
Transverse flattop

## Slice phase space ellipses & centroids

- Varying tilt along z
  - Smaller/higher correlations in tails than in centre
- Shift in centroid positions
  - (Mainly) linear shift in centre



## Emittance decomposition

- Good agreement of measurement & simulation

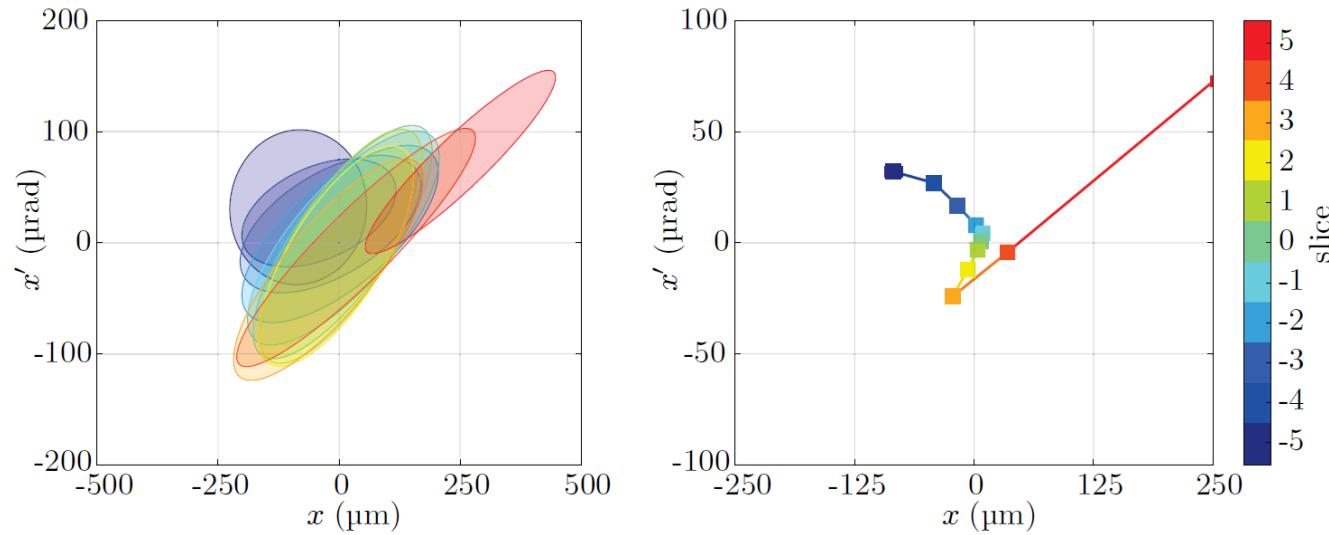
$\pm \text{FWHM}/2$	Measurement	Simulation
Projected emittance	0.57 μm	0.52 μm
Slice emittance	0.50 μm	0.49 μm
Mismatch emittance	0.23 μm	0.19 μm
Linear misalignment emittance	0.10 μm	0.01 μm
Non-linear misalignment emittance	< 0.01 μm	< 0.01 μm

# Slice emittance measurement

Temporal Gaussian  
Transversely-truncated Gaussian

## Slice phase space ellipses & centroids

- Varying emittance & orientation visible



## Emittance decomposition

- Mismatch emittance much larger in simulation

$\pm\text{FWHM}/2$	Measurement	Simulation
Projected emittance	0.47 μm	0.60 μm
Slice emittance	0.45 μm	0.45 μm
Mismatch emittance	0.13 μm	0.40 μm
Linear misalignment emittance	0.06 μm	0.01 μm
Non-linear misalignment emittance	< 0.01 μm	< 0.01 μm

# Summary & outlook

# Summary

## Slit scan + TDS allows slice emittance measurement

- Systematic error acceptable
- Temporal resolution improved with focusing to 200 fs

→ Reliable slice emittance calculation

## Signal-to-noise ratio increased

- LYSO screens, optimised screen station, quadrupole focusing, wider slit opening
- Improved time resolution allows reduction of TDS voltage

} → For PITZ parameters:  
Syst. error ~ 4 %

## Several beams characterised

- Emittance reduced by going from temporal Gaussian to flattop
- Transversely-truncated Gaussian reduces emittance further

$$\epsilon_x = 0.69^{+0.05}_{-0.03} \text{ (stat.) } \mu\text{m}$$
$$\epsilon_x = (0.50 \pm 0.01) \text{ (stat.) } \mu\text{m}$$
$$\epsilon_x = 0.47^{+0.05}_{-0.03} \text{ (stat.) } \mu\text{m}$$

## Emittance decomposition

- Gives insight, how projected emittance can be reduced

Laser pulse profile	
Temporal	Transverse
Gaussian	Flattop
Flattop	Flattop
Gaussian	Truncated Gaussian

# Outlook.

## New laser system for PITZ (NEPAL-P) in 2023

- Higher repetition rate (1 MHz → 4.5 MHz)
- Increase of SNR by factor ~4

→ Narrower slit opening  
might be used

## Upgrade camera

- Electron-Multiplying CCD camera (EMCCD)
- Lower noise improves SNR further

## R'n'D program towards CW-operation of European XFEL

- Reduced gun gradient
- PITZ can characterize beams at cw-gun conditions
- Slice emittance optimisation by laser pulse shaping

# Thank you

PITZ Photo here

## Contact

Deutsches Elektronen-  
Synchrotron DESY  
[www.desy.de](http://www.desy.de)

Raffael Niemczyk  
PITZ Group  
[raffaels.niemczyk@desy.de](mailto:raffaels.niemczyk@desy.de)  
+49 33762/7-7280

# Backup slides

# Estimation of systematic error from finite SNR

Add time profile, detailed PITZ informations

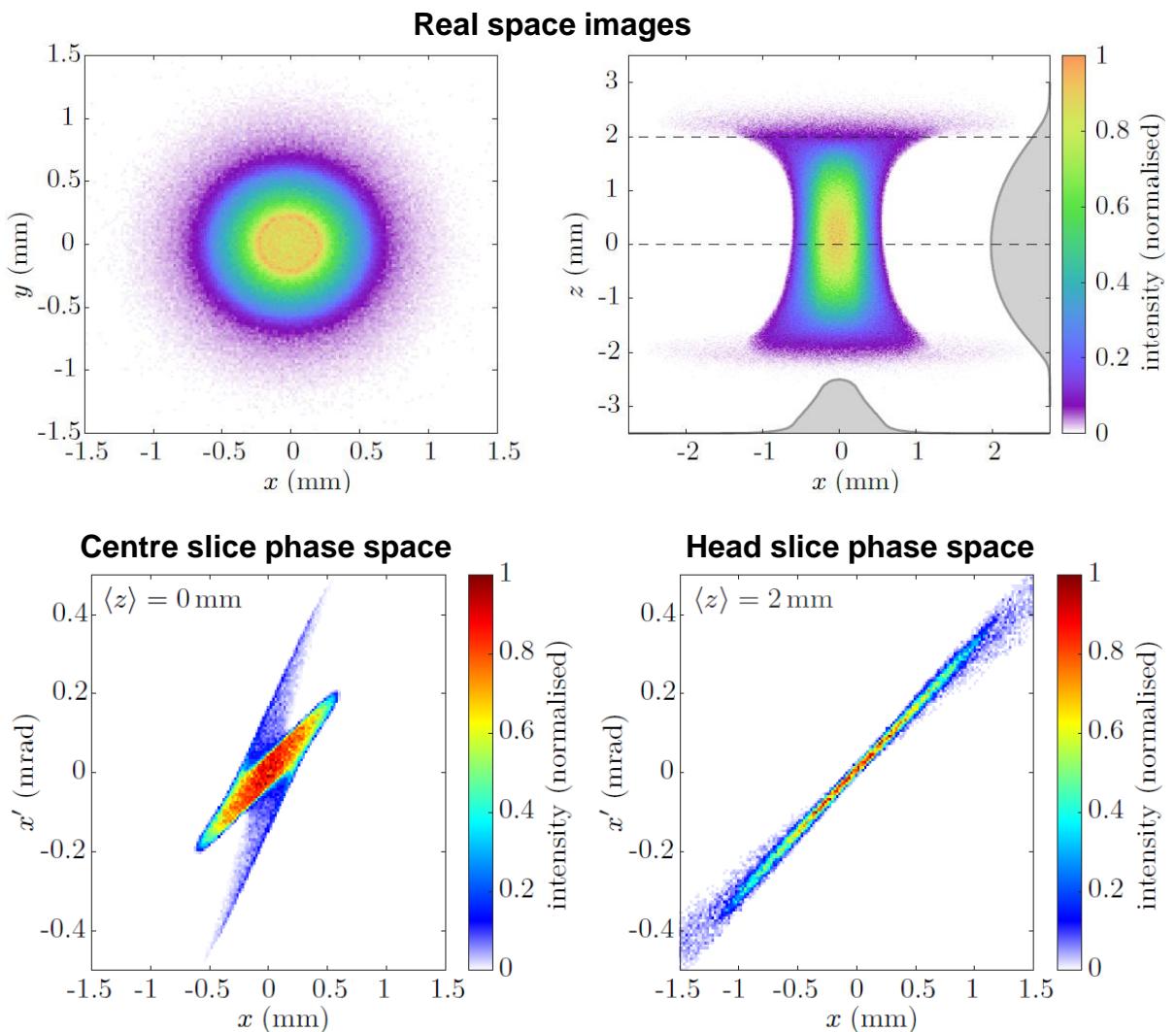
# Laser systems (photos + key properties)

Add time profile, detailed PITZ informations

# Estimation of systematic error

## Start-to-end simulation in ASTRA<sup>[1]</sup>

Beam parameters and results	
Bunch charge	250 pC
Laser pulse length	6 ps (FWHM)
Solenoid current	366 A
Gun momentum	6.32 MeV/c
Beam momentum	19.29 MeV/c
Beam size at EMSY1	0.37 mm
Projected emittance	0.61 $\mu\text{m}$



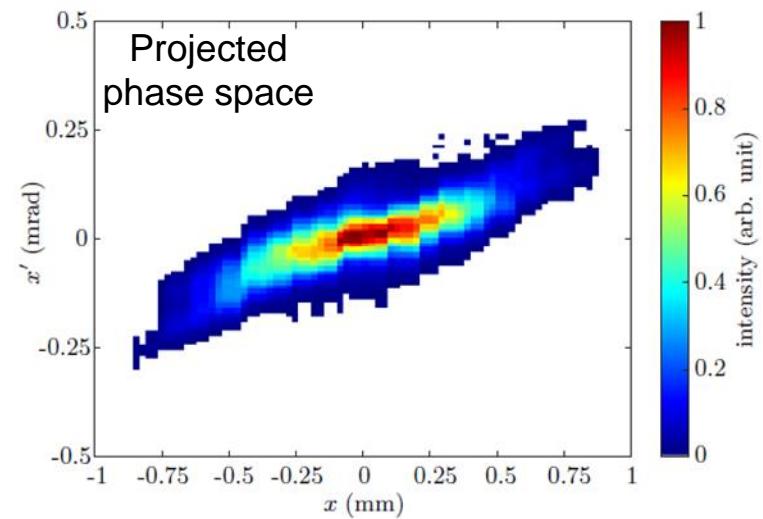
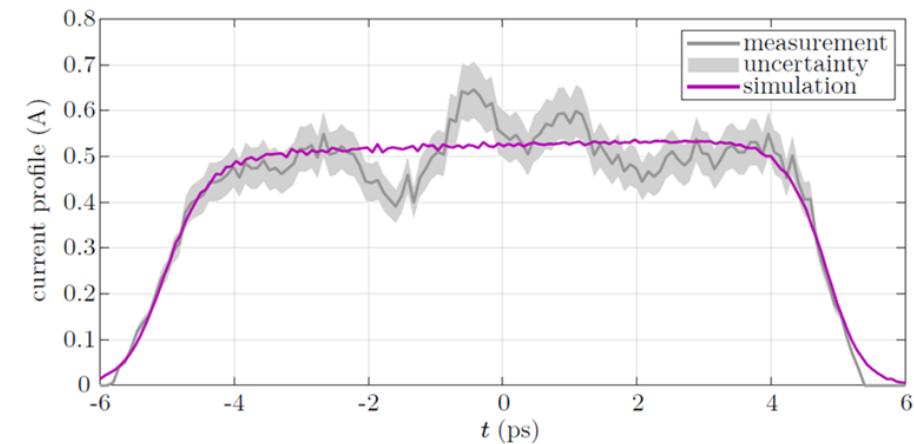
[1] Astra, <https://www.desy.de/~mpyflo/>

# Beam characterisation

Temporal flattop  
Transverse flattop

## Low-emittance beam at Eu-XFEL conditions

- Transverse flattop laser pulse profile
- Temporal flattop laser pulse shape
- 250 pC bunch charge

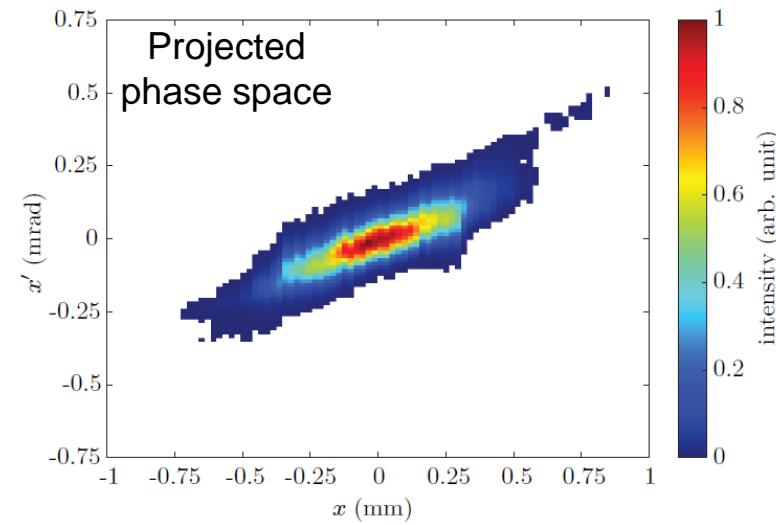
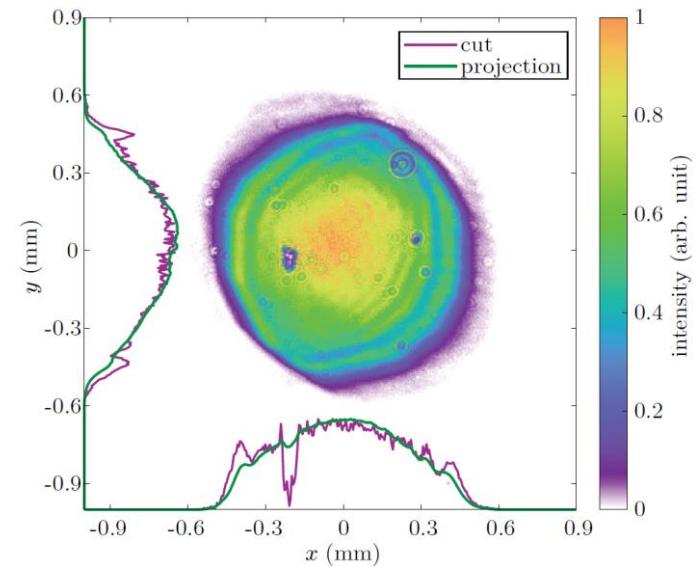


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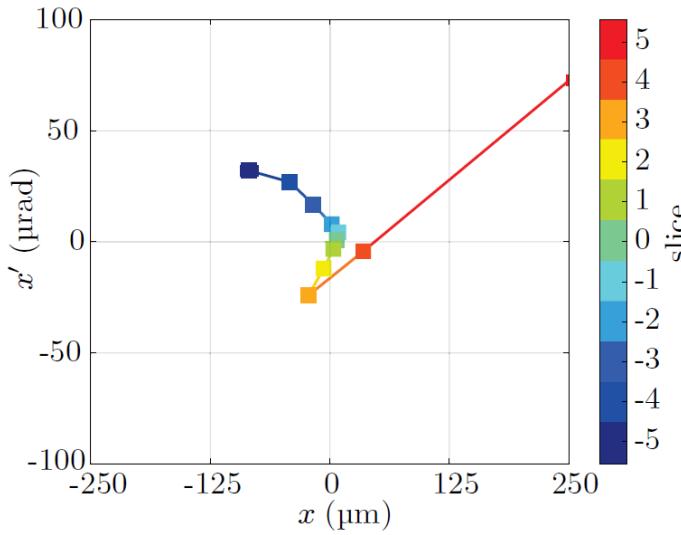
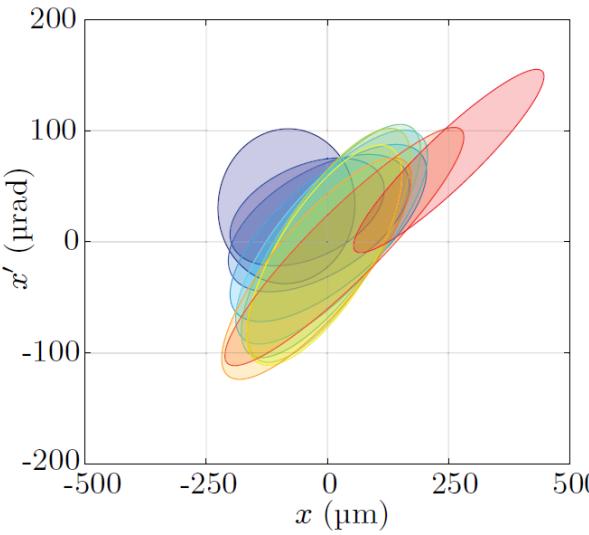
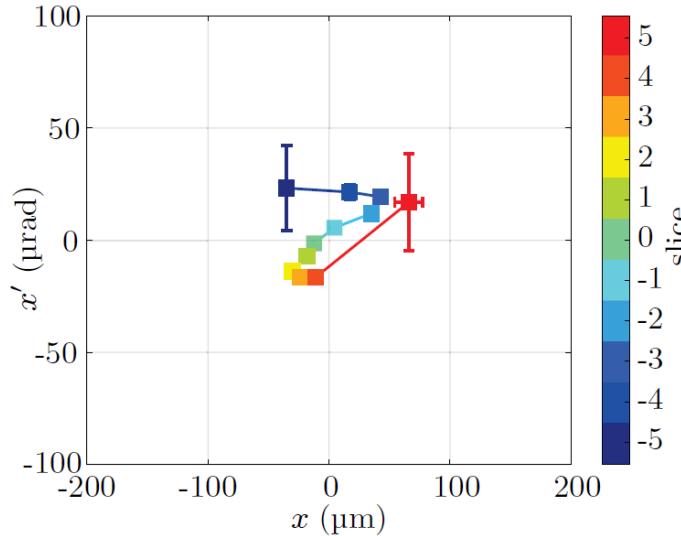
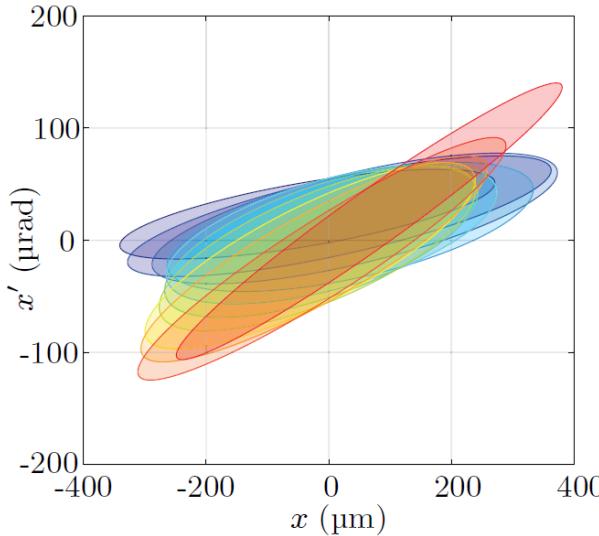
## Low-emittance beam at Eu-XFEL conditions

- Transversely-truncated Gaussian laser pulse profile
- Temporal Gaussian laser pulse shape
- 250 pC bunch charge

Temporal Gaussian  
Transversely-truncated Gaussian



# Slice emittance measurement



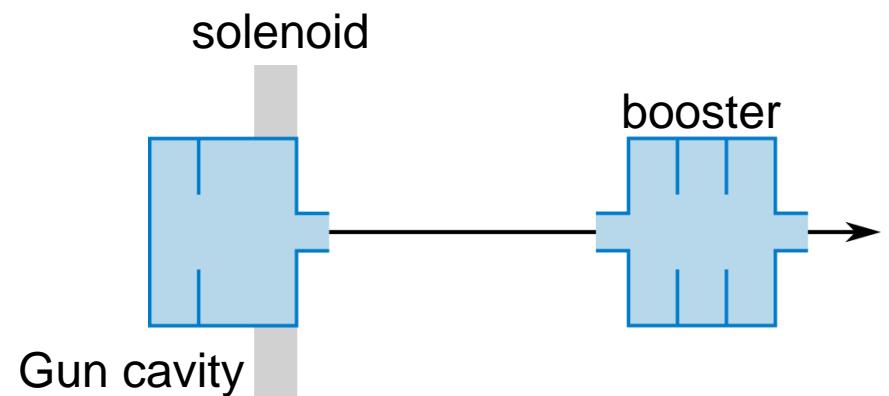
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# Emittance reduction in injector

## Reduce emittance

- Low thermal emittance (from cathode)
  - Low transverse momentum spread
  - Small laser spot size
- Low space charge emittance
  - Reduce SC non-linearities
    - Laser pulse shaping
    - Lower bunch charge
- Gun design
  - High cathode field with gun design (field balance)
  - Pulsed gun
  - High frequency
- Emittance compensation
  - Solenoid focusing into booster entrance
  - Slice PS overlap
- RF stability
  - Emittance measurements are multi-shot



# Info's for me:

# General info's for me

## Subheading, optional

### 01 Talk length

- 20 min presentation
- 5 min questions

### 02 Frank Stephan

- Not only my thesis, but message from PITZ facility

### 03 Check abstract

- What did I tell I would cover?

### 04 Check abstract

- Font size: 14

# General info's for me

## Subheading, optional

**Speaker:** Raffael Niemczyk

**Paper ID**

**Author(s)** Raffael Niemczyk, Zakaria Aboulbanine, Gowri Dulanjalee Adhikari, Namra Aftab, Prach Boonpornprasert, Georgi Zhivkov Georgiev, James David Good, Matthias Gross, Christian Koschitzki, Xiangkun Li, Osip Lishilin, David Melkumyan, Sandeep Kumar Mohanty, Anne Oppelt, Houjun Qian, Seyd Hamed Shaker, Guan Shu, Frank Stephan, Tobias Weilbach (DESY Zeuthen, Zeuthen), Maria Elena Castro Carballo, Mikhail Krasilnikov, Grygorii Vashchenko (DESY, Hamburg), Wolfgang Carl Albert Hillert (University of Hamburg, Hamburg)

**Abstract** Free-electron lasers in the X-ray regime require a high-brightness electron beam, i.e. an electron beam with high current and low transverse emittance. At the Photo Injector Test facility at DESY in Zeuthen (PITZ) high-brightness electron sources are optimized for the use at FLASH and European XFEL. A low transverse emittance of the electron beam's central part, which is assumed to be the lasing slices, is of particular interest for the efficient FEL operation. Over the past years a slice emittance measurement scheme has been developed at PITZ which employs an rf deflector and additional quadrupole magnets along the beamline to the standard measurement procedure for the projected emittance (single-slit scan). It allows measuring the slice emittance in a high-brightness photo injector. Transversely flat-top shaped laser pulses of different temporal distributions (Gaussian and flat-top) have been used to emit electrons, as well as transversely-truncated Gaussian laser pulses with temporal Gaussian shape. The paper shows that the lowest slice emittance in the injector is reached with a temporal flattop shape, or when using a transversely-truncated Gaussian shape.

*Word Count: 175 Character Count: 1164*

# Abstract key points

- Paper shows that lowest emittance is achieved when using flattop or transversely-truncated Gaussian profile
- How to progress: Check content first, then polish slides (fontsize etc.)